DEC 1 0 2003

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q64809

Kenji Matsumoto

Appln. No.: 09/873,218

Group Art Unit: 2828

Confirmation No.: 4028

Examiner: Tuan M. NGUYEN

Filed: June 05, 2001

For:

SEMICONDUCTOR LASOR FABRICATING METHOD OF THE SAME

SUBMISSION OF DRAWINGS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith please find 5 sheet(s) of drawings in compliance with 37 C.F.R. § 1.84. The Examiner is respectfully requested to acknowledge receipt of these drawings.

The submitted drawings incorporate the proposed drawing changes approved in Paper No. 9.

Respectfully submitted,

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WASHINGTON OFFICE

23373
CUSTOMER NUMBER

Date: December 10, 2003

Allison M. Bowles Tulino Registration No. 48,294

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